

<b>LIST OF ART CITED BY APPLICANT</b>  <b>(PTO-1449)</b>	ATTY. DOCKET NO. <b>DPO-0010</b>	APPLN. SERIAL NO. <b>10/714,926</b>
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	FILING DATE <b>November 18, 2003</b>	GROUP <b>2109</b>

**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

**U.S. PATENT APPLICATION PUBLICATIONS**

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

**U.S. PATENT APPLICATIONS**

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	<b>WO 02/27567</b>	<b>04/04/2002</b>	<b>PCT</b>			<b>Abstract</b>	
	<b>JP 2000-25435</b>	<b>09/19/2000</b>	<b>Japan</b>			<b>Abstract</b>	
	<b>CN 1304514</b>	<b>07/18/2001</b>	<b>China</b>			<b>Abstract</b>	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**

	English language translation of Chinese Office Action dated April 24, 2009.

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.